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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Kwang-Kuk LEE

Confirmation No. :3496

Appln. No. : 10/647,351

Group Art Unit: 3732

Filed : August 26, 2003

Examiner: Stephanie L. Willatt

For : PORTABLE NAIL POLISH REMOVER

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

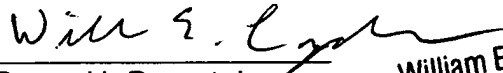
Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Issue Fee
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Notice of Allowability, mailed by the Patent and Trademark Office on October 21, 2005 and to the Statement of Reasons for Allowance attached thereto, Applicant wishes to clarify the record with respect to the basis for the patentability of claims in the present application. In this regard, while Applicant does not disagree with the Examiner's indication that certain identified features are not disclosed by the references, Applicant submits that each of the claims in the present application recite a particular combination of features, and that the basis for patentability of each of these claims is based on the totality of the particular features recited therein.

Should there be any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully submitted,
Kwang-Kuk LEE


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January 23, 2006
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